



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3315**
Makoto IMANISHI et al. : Attorney Docket No. 2004_0092
Serial No. 10/761,412 : Group Art Unit 1725
Filed January 22, 2004 : Examiner Michael Aboagye

METHOD OF FORMING BUMPS ON A : **Mail Stop: Amendment**
WAFER UTILIZING A POST-HEATING
OPERATION, AND AN APPARATUS
THEREFORE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated November 21, 2006, a Petition for a one-month extension of time being submitted herewith, please amend the above-identified application as follows.

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975